

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): William G. America, et al.

Examiner: Jack S. J. Chen

Serial No: 10/674,646

Art Unit: 2813

Filed: September 30, 2003

Docket: YOR920030320US1 (16868)

For: PLASMA SURFACE MODIFICATION
AND PASSIVATION OF ORGANO-
SILICATE GLASS FILMS FOR
IMPROVED HARDMASK ADHESION
AND OPTIMAL RIE PROCESSING

Dated: March 26, 2008

Confirmation No. 4797

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.111

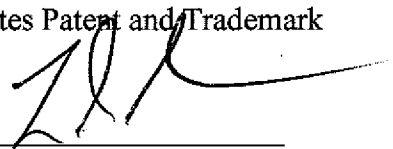
Sir:

In response to the Office Action dated January 2, 2008, Applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website on March 26, 2008.

Dated: March 26, 2008



Leslie S. Szivos, Ph.D.